

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Noriyoshi SATO et al.

Application No.: 10/539,569

Filed: June 17, 2005

Docket No.: 124305

For: PLASMA GENERATOR, OZONE GENERATOR, SUBSTRATE PROCESSING  
APPARATUS, AND METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification;**

**Remarks.**